

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/602,467 PATENT
Filing Date: June 23, 2003 Attorney Docket No. 101453-00079 SP#103
Inventor(s): Venkat SELVAMANAICKAM
Group Art Unit: 1762
Examiner Name: Not Yet Assigned
Customer No.: 026304
Title: **APPARATUS FOR HIGH-THROUGHPUT ION
BEAM-ASSISTED DEPOSITION (IBAD)**

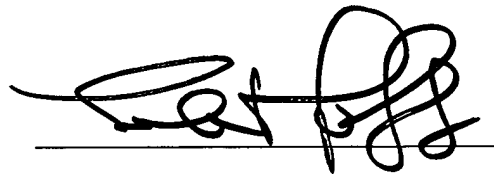
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST TO MAKE SPECIAL

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By: _____



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